FORM PTO-1449 U.S. DEPARTMENT OF CO (REV.7-80) INFORMATION DISCLOSURE STATEMENT (Uso several sheets if necessary)					ATTY. DOCKET NO. 856063.720D1 APPLICANT Raffaele Zambrano FILING DATE	APPLICATION NO. \O/GIS,961 O GROUP ART UNIT				
					July 8, 2003		1.2	-818		
			U.S.	PATENT	DOCUMENTS		-	, ,	FILING	DATE
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE		NAME	CL	CLASS SUBC		IF APPROPRIATE	
THE	АА	5,475,248	12/12/95	Takenaka		257		295	*****	
_	ΑB	5,481,490	01/02/96	Watanab	e et al.	365		145		
	AC	5,578,867	11/26/96	Argos, Jr. et al.		257		632	-	
	ΑĐ	5,638,319	06/10/97	Onishi et al.		365		145		
,	AE,	5,716,875	02/10/98	Jones, Jr. et al.		438		3		
	AF	5,750,419	05/12/98	Zafar		438		3.		
	AG	5,811,847	09/22/98	Joshi et al.		257	ا 	296	<u> </u>	
	АН	5,864,153	01/26/99	Nagel et	al.	257		296		
	Al	5,956,594	09/21/99	Yang et	438		396		<u> </u>	
TIO	ΙA	5,965,942	12/12/99	Itoh et al	257	7 '-	761			
			FORE	GN PATE	NT DOCUMENTS	· · ; .		• • •		
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720	AK	0793274A1	09/03/97	EP				· ·	. X	
1	AL	WO 98/05071	02/05/98	WIPO			·			ļ
	AM	19640246A1	04/02/98	DE						x
	AN	0 837 504 A2	04/22/98	EP	·					
THE	AO	0 996 160 A1	06/26/00	EP						
		OTH	ER PRIOR	ART (Includi	ng Author, Title, Date, Pertl	nenį Pages, E	tc.)	·		
THE	AP.	Yamazaki, of Half-Mid December 1	T. et al., "Ad ron CMOS l	vanced 0.	5μm FRAM Device ce", IEEE, pp. 25.5	Technol	ogy v	with Full C 000855871	compati ,	bility
	AQ		<u> </u>	<u> </u>	<u> </u>	- 		· ·		٠.
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*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME		CLA	SS SUBCLASS		G DATE OPRIATE	
THE	AA	5,973,342	10/26/99	Nakamura		257	295			
<u>'</u>	AB	5,981,382	11/09/99	Konecni et al.		438	646	-		
<u> </u>	AC	5,990,507	11/23/99	Mochizuki et al.		257	295	•		
	ΑD	5,994,153	11/30/99	Nagel et al. Saran et al.		438	3			
	AE.	5,998,296	12/07/99			438	685			
	ΑF	6,037,252	03/14/00	Hillman et al.			637			
	AG	6,043,529	03/28/00	Hartner et al.			306			
	ΑH	6,051,858	04/18/00	Uchida et	al.	257	295	-		
	AI	6,075,264	06/13/00	Koo		257	295			
THE	AJ	6,091,599	07/18/00	Amamiya		.361	306.3			
			FOREI	GN PATEN	IT DOCUMENTS				1	
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Sheet 3 of 3 FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE ATTY, DOCKET NO. APPLICATION NO. (REV.7-80) PATENT AND TRADEMARK OFFICE 856063.720D1 APPLICANT INFORMATION DISCLOSURE STATEMENT Raffaele Zambrano (Use several sheets if necessary) FILING DATE GROUP ART UNIT July 8, 2003 · **U.S. PATENT DOCUMENTS** *EXAMINER DOCUMENT NUMBER DATE FILING DATE INITIAL NAME CLASS SUBCLASS IF APPROPRIATE 6,121,083 ٨٨ 09/19/00 Matsuki 438 254 ΑB 6,180,974 01/30/01 Okutoh et al. 257 306 6,194,311 02/27/01 AC Nakajima 438 660 6,197,631 03/06/01 Ishihara ΑD 438 240 6,239,460 05/29/01 ΑE Kuroiwa et al. 257 300 6,281,537 08/28/01 Kim АF 257 295 AG 6,313,539 11/06/01 Yokoyama et al. 257 761 AH AJ **FOREIGN PATENT DOCUMENTS** DOCUMENT TRANSLATION DATE NUMBER YES NO ΑK AL AM AN AQ OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.) AP AQ. AR EXAMINER -DATE CONSIDERED

* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in

conformance and not considered. Include copy of this form with next communication to applicant(s).

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Date: 7/8/03